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CPC **F22B 1/284** (2013.01)(21) Appl. No.: **15/215,313**(57) **ABSTRACT**(22) Filed: **Jul. 20, 2016****Related U.S. Application Data**

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A chamber body is to receive therein a substance that is to be vaporized or sublimated into a vapor. A plate whose bottom face rests on the substance inside the chamber body is temperature regulated, e.g., using a heater therein, which releases heat directly above the substance that lies below. The plate slides downward as the substance is consumed by vaporization or sublimation. Other embodiments are also described and claimed.

